

# X axis | X65P84S/K250

Piezoelectric macro - micro composite platform





Macro micro composite piezoelectric platform is to point to in the micrometer integration on the basis of the piezo positioning platform, hand the micrometer can be 13 mm stroke of macro regulation, piezoelectric movement platform can be 250 microns stroke of nanoscale micro adjustment, and micrometer adjustment accuracy on the platform of piezoelectric motor adjustment range, so as to ensure the precision of adjustment and convenient.

#### Characteristics >>

- Motion in X
- Selectable sensor
- Manual micrometer displacement to 13mm, resolution to 10µm
- Piezo displacement up to 250µm, reslution to 2nm
- Custom longer coarse/fine travel is available

#### Applications >>

- Optical alignment
- · Cell manipulation
- Precision positioning
- Micromachining/precision control



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## Technical Data >>

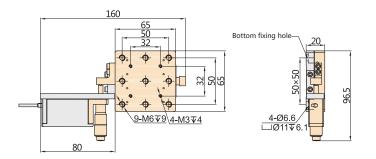
|                                      | S- Closed loop |                   |             |          |
|--------------------------------------|----------------|-------------------|-------------|----------|
| Туре                                 | K- Open loop   | X65P84S250        | X65P84K250  | Units    |
| Active axes                          |                | X                 | Χ           |          |
| Travel range(coarse+fine)            |                | 13+250/axis       | 13+250/axis | mm+µm    |
| Meterial                             |                | Steel,Al          | Steel,Al    |          |
| Manual Adjustment - Micrometer       |                |                   |             |          |
| Travel range                         |                | 13/axis           | 13/axis     | mm       |
| Resolution                           |                | 10                | 10          | μm       |
| Driving mode                         |                | Screw thread pair |             |          |
| Sensitivity                          |                | <2                | <2          | μm       |
| Least count                          |                | 10                | 10          | μm/div   |
| Screw pitch                          |                | 0.5               | 0.5         | mm/rev.  |
| Piezo Adjustment - Piezo             |                |                   |             |          |
| Travel range                         | 0~120V         | 200/axis          | 200/axis    | μm±20%   |
|                                      | 0~150V         | 250/axis          | 250/axis    |          |
| Sensor                               |                | SGS               | -           |          |
| Min step (resolution)                |                | 7                 | 2           | nm, typ. |
| Closed-loop linearity                |                | 0.1               | -           | %F.S.    |
| Repeatability                        |                | 0.05              | -           | %F.S.    |
| Push force capacity                  |                | 8                 | 8           | N        |
| Stiffness                            |                | 0.03              | 0.03        | N/       |
|                                      |                |                   |             | μm±20%   |
| Load(Z axis)                         |                | 1.3               | 1.3         | kg       |
| Mass                                 |                | 500               | 500         | g±5%     |
| E.I capacitance                      |                | 7.2/axis          | 7.2/axis    | μF±20%   |
| Operating temperature <sup>[1]</sup> |                | -20~80            | -20~80      | °C       |
| Cable <sup>[2]</sup>                 |                | 1.5               | 1.5         | m±10mm   |
| Connector <sup>[2]</sup>             |                | LEMO              | LEMO        |          |
|                                      |                |                   |             |          |

Note: Max driving voltage could be  $-20V\sim150V$ , recommended voltage  $0\sim120V$  for long-term and high-reliable operation to extend lifetime. Technical data is measured by CoreMorrow E00/E01 series piezo controller.

- [1] Custom ultralow temperature and ultrahigh vacuum versions are available.
- [2] Custom cable length and connector is available.

Note: The parameters mentioned above are related to the test environment and test equipment.

### Drawing >>



## Composition >>

| Piezo stage  | Micrometer  |
|--------------|-------------|
| 250µm Travel | 13mm Travel |
|              |             |

## Recommended Controllers >>



E01.D1 LCD, membrane button, up to 625mA RS-232/RS-422/USB interface Software secondary development



E53 Small size, 60mA RS-232/RS-422/USB interface Software secondary development



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